

Docket No. TIP287US

TI-35996



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re **PATENT** application of:

Applicant: K.R. Udayakumar et al.

Application No.: 10/620,516

For: HYDROGEN BARRIER FOR PROTECTING FERROELECTRIC
CAPACITORS IN A SEMICONDUCTOR DEVICE AND METHODS
FOR FABRICATING THE SAME

Filing Date: July 16, 2003

Examiner: Sara W. Crane

Art Unit: 2811

REPLY TO OFFICE ACTION DATED DECEMBER 14, 2004

Mail Stop Amendment
Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Favorable reconsideration of the above-identified application is respectfully requested in view of the following amendments and remarks.